

Pulsed Laser Epitaxy of p-type ZnO Realizing Light Emitting Diode

Masashi Kawasaki^{1,2}

¹ Institute for Materials Research (IMR), Tohoku University, Sendai 980-8577, Japan

² Combinatorial Materials Exploration and Technology (COMET), National Institute for Materials Science (NIMS), Tsukuba 305-0044, Japan

We report on a conversion of ZnO into *p*-type by nitrogen doping during laser molecular beam epitaxy (L-MBE), which enables us to fabricate blue light emitting diode based on ZnO *p-n* junctions. Behind the success, much effort has been paid to make non-doped ZnO as perfect as possible. We have marked records of the mobility ($400\text{cm}^2/\text{Vs}$ @300K and $>5,000\text{cm}^2/\text{Vs}$ @100K) and exciton radiative recombination lifetime ($>2.5\text{ns}$ @300K), both of which surpass to the values achieved in world-best bulk single crystals. The residual electron concentration is as low as 10^{15}cm^{-3} with keeping such high quality properties. The use of ScAlMgO₄ substrate and proper buffer layer make it possible to grow such thin films in a persistent layer-by-layer growth mode in L-MBE [1].

Another trick was to incorporate nitrogen with high concentration (10^{20}cm^{-3}) with keeping such high crystalline quality by using “repeated temperature modulation technique” [2]. In this process, we repeated 15nm of nitrogen doped ZnO growth at 400°C, rapid rump of temperature to 1000°C, and additional growth of 1nm ZnO at the high temperature for making several hundreds nm thick films. The films show clear and reproducible *p*-type conduction as revealed by Hall effect with a hole concentration of 10^{16} - 10^{17}cm^{-3} and an activation energy of 100meV. We observed 420nm emission upon forward bias current drive for *p-i-n* junctions. The radiative recombination in the *p*-type ZnO by the electron injection into that layer seems to dominate.

As future challenges, we pursue higher hole concentration ($>10^{18}\text{cm}^{-3}$), doping of (MgZn)O into *p*-type and the use of ZnO single crystal substrates with aiming at practical devices.

[1] A. Tsukazaki, A. Ohtomo, S. Yoshida, M. Kawasaki, C. H. Chia, T. Makino, Y. Segawa, T. Koida, S. F. Chichibu, and H. Koinuma, *Appl. Phys. Lett.* **83**, 2784 (2003)

[2] A. Tsukazaki, T. Onuma, M. Ohtani, T. Makino, M. Sumiya, K. Ohtani, S.F. Chichibu, S. Fuke, Y. Segawa, H. Ohno, H. Koinuma, M. Kawasaki, *Nature Materials*, **4**, 42 (2005)